

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: **Mutsumi YANO, et al.**

Serial Number: **Not Yet Assigned**

Filed: **July 3, 2003**

For: **ELECTROLYTIC CAPACITOR AND A FABRICATION METHOD THEREFOR**

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

July 3, 2003

Sir:

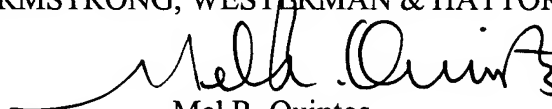
In compliance with 37 CFR 1.56, Applicants call to the attention of the Patent and Trademark Office the references listed on the attached PTO-1449.

A copy of each of the references are enclosed herewith.

In the event there are any fees due in connection with the filing of this paper, please charge Deposit Account No. 01-2340.

Respectfully submitted,

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PATENT TRADEMARK OFFICE

Enclosures: PTO-1449; References (3)

INFORMATION DISCLOSURE STATEMENT PTO-1449	Atty. Docket No. 030744	Serial No. New Application
	Applicant(s): Mutsumi YANO, et al.	
	Filing Date: July 3, 2003	Group Art Unit: Not Yet Assigned

U.S. PATENT DOCUMENTS

Examiner Initial	Document No.	Name	Date	Class	Subclass	Filing Date (If appropriate)
_____	AA					
_____	AB					
_____	AC					
_____	AD					

FOREIGN PATENT DOCUMENTS

Document No.	Date	Country	Translation (Yes or No)
_____ AE 5-121275	05/18/93	Japan	Yes-Abstract/Discussed in the specification
_____ AF 11-312628	11/09/99	Japan	Yes-Abstract/Discussed in the specification
_____ AG			
_____ AH			
_____ AI			

OTHER DOCUMENTS

_____	AJ	G.E. Thompson et al.; "The Migration of Fluoride Ions in Growing Anodic Oxide Films on Tantalum"; <i>Journal Electrochemical Society</i> ; Vol. 144; No. 2; pp. 418-423, February, 1997.
_____	AK	
Examiner		Date Considered